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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Inventor(s):

Arman Gasparyan

Timofei Nikita Kroupenkine

Joseph Ashley Taylor

Donald Weiss

Case:

4-20-11-6

Serial No.:

10/816569

Filing Date:

April 1, 2004

Examiner:

Group Art Unit:

2832

Title:

Liquid Electrical Microswitch

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

SIR:

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

In accordance with 37 CFR 1.97(b), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

Copies of the listed documents are enclosed together with the search report that listed these documents.

NO FEE IS REQUIRED

In the event of any non-payment or improper payment of a required fee, the Commissioner is authorized to charge or to credit **Lucent Technologies Deposit Account No. 12-2325** as required to correct the error.

Respectfully

David W. Herring, Attorney

Reg. No. 51069

908-582-4326

Date:

Docket Administrator (Room 3J-219)

Lucent Technologies Inc. 101 Crawfords Corner Road Holmdel, NJ 07733-3030

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on July / , 2004.

Rose E. Ewald

IFW

INFORMATION DISCLOSURE STATEMENT				Serial No. Applicant:	A. Gasparyan, et al. April 1, 2004		
0 6 2004 필			U.S. PATENT	DOCUMENTS			
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^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant